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#47  
5-3-03  
JA

S&H Form: (2/01)  
Attorney Docket No. 826.1605

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Hiroaki Takebe et al.

Application No.: 09/577,340

Group Art Unit: 2621

Confirmation No.: 5834

Filed: May 24, 2000

Examiner: Tom Y Lu

For: PATTERN SEGMENTATION APPARATUS AND PATTERN RECOGNITION  
APPARATUS

RESPONSE TO RESTRICTION REQUIREMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In response to the Office Action mailed March 25, 2003, applicant(s) elect(s) Figure 3 of  
Species 1, without traverse. Figure 3 corresponds to claims 1-17 and 19-21.

Respectfully submitted,

STAAS & HALSEY LLP

Date:

4/25/3

By:

J. Randall Beckers  
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**LETTER TO THE EXAMINER REQUESTING  
APPROVAL OF THE CHANGES TO THE DRAWINGS**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

It is respectfully requested that the Examiner having jurisdiction over the subject application approve the amendments to the drawings as indicated in RED on the attached copy of Figure 3.

Respectfully submitted,

STAAS & HALSEY LLP

Date: 4/25/03

By: J. Randall Beckers

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